"RESPONSE UNDER 37 CFR 1.118-EXPEDITED PROCEDURE EXAMINING GROUP___1763 •

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

TSUTOMU OKABE, ET AL. : EXAMINER: MOORE, K.

SERIAL NO: 10/706,915

FILED: NOVEMBER 14, 2003 : GROUP ART UNIT: 1763

FOR: WAFER PROCESSING

APPARATUS HAVING DUST PROOF

FUNCTION

AMENDMENT

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated December 12, 2006, please amend the aboveidentified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.